



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of

Terunao HANAOKA

Group Art Unit: 2822

Application No.: 10/679,467

Examiner: T. TRAN

Filed: October 7, 2003

Docket No.: 117462

For: SEMICONDUCTOR WAFER,  
SEMICONDUCTOR DEVICE AND METHOD  
OF MANUFACTURING THE SAME,  
CIRCUIT BOARD, AND ELECTRONIC  
EQUIPMENT

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)  
continued examination.

☒ Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper  
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 178320 in the amount of ☒ \$790.00 as payment of the fees  
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees  
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two  
duplicate copies of this page are enclosed.

Respectfully submitted,

03/31/2006 HALI11 00000030 10679467

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790.00 DP

James A. Oliff  
Registration No. 27,075

Gang Luo  
Registration No. 50,559

JAO:GXL/sqb

Date: March 29, 2006

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461